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CONFIRMATION NO. 5271

SERIAL NUMBER 10/670,356	FILING DATE 09/26/2003 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 520.39728VX1	
APPLICANTS Mutsuko Hatano, Kokubunji, JAPAN; Shinya Yamaguchi, Mitaka, JAPAN; Yoshinobu Kimura, Tokyo, JAPAN; Seong-Kee Park, Hachioji, JAPAN; ** CONTINUING DATA ***** This application is a DIV of 09/791,853 02/26/2001 PAT 6,756,614 ** FOREIGN APPLICATIONS ***** JAPAN 2001-19570 01/29/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/20/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
ADDRESS 020457 ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800 ARLINGTON , VA 22209-3873					
TITLE Thin film semiconductor device, polycrystalline semiconductor thin film production process and production apparatus					
			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing)		